



Attorney Docket No.: 033082M354

PATENT

ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hiroki OHNO, et al.
U.S. Serial No.: 10/594,549 Group Art Unit: To Be Assigned
Filed: September 27, 2006 Examiner: To Be Assigned
For: SUBSTRATE CLEANING METHOD, SUBSTRATE CLEANING
EQUIPMENT, COMPUTER PROGRAM, AND PROGRAM
RECORDING MEDIUM

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the reference cited in an Office Action issued in counterpart Chinese Patent Appln. No. 200580012831.X.

No Office Action has issued for this application and therefore no fees are believed necessary in connection with this Statement.

It is respectfully requested that the cited document be considered by the Examiner in the above-identified patent application and that the cited document be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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